PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
TOSHIHIKO TAKEDA	01/24/2014
HIROYUKI NISHIMURA	01/24/2014
KATSUNARI OBATA	01/27/2014

RECEIVING PARTY DATA

Name:	DAI NIPPON PRINTING CO., LTD.	
Street Address:	1-1, ICHIGAYA-KAGACHO 1-CHOME	
Internal Address:	SHINJUKU-KU	
City:	TOKYO	
State/Country:	JAPAN	
Postal Code:	162-8001	

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	14923497

CORRESPONDENCE DATA

Fax Number: (703)685-0573

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

Phone: 7035212297

Email: yreynolds@young-thompson.com

Correspondent Name: YOUNG & THOMPSON Address Line 1: 209 MADISON STREET

Address Line 2: SUITE 500

Address Line 4: ALEXANDRIA, VIRGINIA 22314

ATTORNEY DOCKET NUMBER:	8014-1224-1
NAME OF SUBMITTER: ERIC JENSEN	
SIGNATURE:	/Eric Jensen/
DATE SIGNED:	10/27/2015
	This document serves as an Oath/Declaration (37 CFR 1.63).
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Total Attachments: 1

PATENT REEL: 036888 FRAME: 0051

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PATENT REEL: 036888 FRAME: 0052

ASSIGNMENT AND INVENTOR'S DECLARATION

WHEREAS I/we, the undersigned inventor(s), hereafter also referred to as "assignor(s)", have invented certain new and useful improvements described in the application identified below; and

WHEREAS, <u>DAI NIPPON PRINTING CO., LTD.</u>, hereinafter referred to as "assignee(s)", whose address is <u>1-1</u>, <u>Ichigaya-kagacho 1-chome</u>, <u>Shinjuku-ku</u>, <u>Tokyo 162-8001 Japan</u>, is desirous of acquiring the entire right, title and interest in and to the application and invention, and to any United States patents to be obtained therefor;

NOW, THEREFORE, for valuable consideration, the receipt and sufficiency of which is hereby acknowledged, I/we, the above-named assignor(s), hereby sell, assign and transfer to the above named assignee(s), its successors and assigns, the entire right, title and interest in the application and the invention disclosed therein for the United States of America, including all divisions, and continuations thereof, and all Letters Patent of the United States that may be granted thereon, and all reissues thereof, including any right to bring or maintain an action for infringement under the provisional rights granted pursuant to Title 35, Section 154 of the United States Code or any other cause of action for acts which would constitute infringement occurring prior to this assignment, and including the right to claim priority under the International Convention of Paris (1883), as amended, of or in any corresponding foreign patent application, and I/we request the Director of the U.S. Patent and Trademark Office to issue any Letters Patent granted upon the invention set forth in the application to the assignee(s), its successors and assigns.

As a below named inventor, I here	∍by d	eclare that:
This assignment and declaration is directed to:		The attached application, or
	\boxtimes	United States Application or PCT International Application Number
		filed on [(Confirmation No).
ORGANIC SEMICONDUCTOR ELE The above-identified application v	MENI vas m	R PRODUCING VAPOR DEPOSITION MASK, AND METHOD FOR PRODUCING and an authorized to be made by me. Or an original joint inventor of a claimed invention in the application.
•		false statement made in this assignment with declaration is punishable ment of not more than five (5) years, or both.
ivan Marra(a) Tanhihika	****	Family Name/Surname(s) TAKEDA

Inventor's gan 24, 2014 Joshihiko Date Signature: Family Name/Surname(s) **NISHIMURA** Hiroyuki Given Name(s) Inventor's Date Signature: Family Name/Surname(s) **OBATA** Katsunari Given Name(s) Inventor's Obata Signature: Date Family Name/Surname(s) Given Name(s) Inventor's **Date PATENT** Signature: REEL: 036888 FRAME: 0053 RECORDED: 10/27/2015